

DOCKET NO: 287800US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
MASAYUKI OIKAWA, ET AL. : EXAMINER: CHAN, CEDRIC A.
SERIAL NO: 10/574,286 :
FILED: MARCH 31, 2006 : GROUP ART UNIT: 1797
FOR: INSPECTION METHOD AND :
INSPECTION ASSISTING DEVICE FOR
QUARTZ PRODUCT OF
SEMICONDUCTOR PROCESSING
APPARATUS

SUPPLEMENTAL AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Supplemental to the Amendment filed May 24, 2010 in response to the Office Action dated February 22, 2010, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.